



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

March 9, 2026	
IGI Report Number	LG779629090
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	7.83 - 7.86 X 4.82 MM

GRADING RESULTS

Carat Weight	1.81 CARAT
Color Grade	F
Clarity Grade	VS 1
Cut Grade	IDEAL

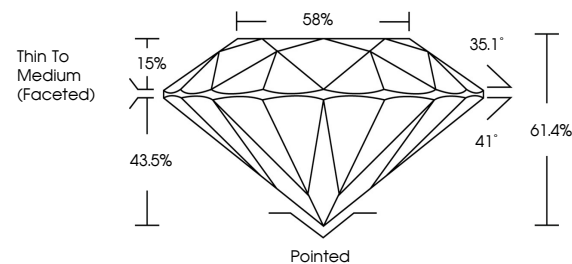
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG779629090

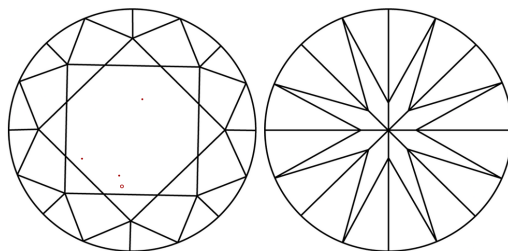
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG779629090
Report verification at igi.org

PROPORTIONS

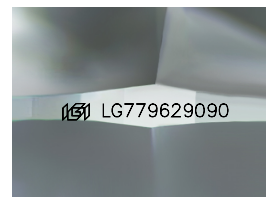


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

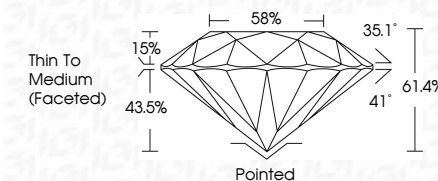
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www.igi.org

March 9, 2026	1.81 CARAT
GI Report No LG7962090	F
ROUND BRILLIANT	VS 1
	IDEAL
	61.4%
	85%
	Thin To Medium
	(Fractured)
	Pointed
	EXCELLENT
	EXCELLENT
	NONE
	689 LG7962090
	Comments:
	The Laboratory Grown Diamond was
	created by Chemical Vapor Deposition
	(CVD) growth process.
	Type IIA